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IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
MASANOBU IGETA, ET AL. : EXAMINER: LEE, CHEUNG
SERIAL NO: 10/527,642 :
FILED: MARCH 14, 2005 : GROUP ART UNIT: 2812
FOR: METHOD FOR FORMING :
INSULATING FILM ON SUBSTRATE,
METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE AND
SUBSTRATE-PROCESSING APPARATUS

AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Responsive to the Office Action mailed April 3, 2007, please amend the above-identified patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.